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VERTICAL ELECTROPOLISHING OF 704MHZ RESONATORS USING NINJA CATHODE: GRADIENTS OVER 40MV/M ACHIEVED ON ESS SINGLE-CELL CAVITY

F. ÉOZÉNOU[#] , M. BAUDRIER, E. CENNI, E. FAYETTE, G. JULLIEN, L. MAURICE, C. SERVOUIN CEA, DSM/IRFU/DACM, CEA-SACLAY, F-91 191 GIF-SUR-YVETTE

> Y. IDA, K. NII, T. YAMAGUCHI MGH, HYOGO-KEN, JAPAN

H. HAYANO, H. ITO, S. KATO, T. KUBO, H. MONJUSHIRO, T. SAEKI KEK, IBARAKI, JAPAN







F. EOZENOU

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704MHZ ACTIVITIES AT CEA





ESS Cryomodule assembly at CEA SACLAY On-going

Cryomodule Assembly



Treatment of β=1 SPL Cavity (2014) (EuCard): Electropolishing (EP)



Treatment of ESS proto M-beta (2016): Standard 'BCP' Chemical polishing

Cavity Preparation

Goal of the presented study:

- Improving the performance of 704MHz resonators for future applications
- Demonstrating superiority of Electropolishing Vs Standard Chemical treatment
- Investigate effect of heat treatments

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PREVIOUS EXPERIENCE WITH SPL CAVITY VERTICAL EP WITH ROD CATHODE (2014)







Typical surface morphologies after >100 μ m VEP at different locations.

- The weldings at a) equators, and b) irises are smooth.
- Bubbles stripes are observed at the proximity of irises c) and d).
- In the areas between equators and irises e) the surface is rougher.

IMPROVEMENT OF HYDROGEN EVACUATION MANDATORY

NEW APPROACH: ROTATING CATHODE COLLABORATION CEA/KEK/MARUI





1-Cell cavity on VEP set-up

ESS β=0.86 geometry, 1-cell

- Supplier: Zanon RI
- Nb: Tokyo Denkai Fine grain RRR>300
- VEP with rotating Ninja cathode
- Surface quality > BCP
- Symetric removal





Equator surface (80µm average removal)

ROTATING TECHNOLOGY 'Ninja' Cathode

Cavity has been tested at 2K before any heat treatment (200µm total removal)



Working Parameters:

- U: 20V
- Acid flowrate: >15L/min
- T<15°C
- External Cooling of cavity wall
- 20rpm rotation









Excellent RF Performance achieved after Heat Treatments:

- Quench @ 33MV/m (2K) after Heat treatment at 650°Cx10h + Excellent Rs.
- = <u>Superiority Vs BCP</u>

Eacc = 45MV/m after mild baking 120°Cx48h

Heat Treatment @ 650°C done at



ONGOING VEP ACTIVITIES





- Scale the process to 5-Cell β=0.86 ESS cavity. Cavity and cathode available
- Test 2-step baking on 1-Cell and 5-Cell cavities



Excellent RF Peformance after VEP + '2-step baking' (FERMILAB recipe) at 75°C-120°C on Tesla 1300MHz single-cell cavity





HB03 ESS-prototype cavity to be treated by VEP with dedicated cathode.



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THANKS